

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Martin, et al.

Group Art Unit: 1763

App. No.: 10/784,697

Examiner: Maureen G. Arancibia

Filed: February 23, 2004

Confirmation No. 1334

Docket No.: 62002-1752

For: **METHOD AND APPARATUS FOR LOW ENERGY ELECTRON ENHANCED ETCHING  
OF SUBSTRATES IN AN AC OR DC PLASMA ENVIRONMENT**

**AMENDMENT AFTER ALLOWANCE**

Mail Stop: Issue Fee  
P.O. Box 1450  
Commissioner for Patents  
Alexandria, Virginia 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.312, please enter the following amendments. Applicant respectfully submits that the amendments herein merely embody the correction of formal matters and do not alter the scope or substance of the application.

It is not believed that extensions of time or fees for net addition of claims are required, beyond those which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary to allow consideration of this paper, such extensions are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefore (including fees for net addition of claims) are hereby authorized to be charged to deposit account no. 20-0778.